



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81061

HAYASHIDA, Hideki, et al.

Appln. No.: 10/821,944

Group Art Unit: 2818

Confirmation No.: 2372

Examiner: David NHU

Filed: April 12, 2004

For: AMMONIA FOR USE IN MANUFACTURE OF GAN-TYPE COMPOUND SEMICONDUCTOR AND  
METHOD FOR MANUFACTURING GAN-TYPE COMPOUND SEMICONDUCTOR

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This Amendment is submitted in response to the Office Action dated June 9, 2003.

Review and reconsideration on the merits in view of the following remarks and amendments is respectfully requested.

A Terminal Disclaimer is submitted herewith.

Please amend the above-identified application as follows on the accompanying pages.

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